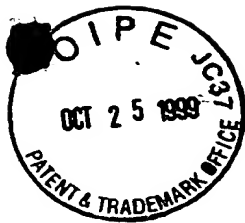


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PATENT APPLICATION

ATTORNEY DOCKET NO.: 98 P 7512 US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Shmuel Shaffer et al.

Serial No.: 09/071,664

Examiner: Unassigned

Filing Date: May 1, 1998

Group Art Unit: 2742

Title: AUTOMATED CALL CONNECTION SYSTEM

THE ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is believed to be submitted before the mailing date of first office action on the merits.

Applicants submit herewith Form PTO 1449 - Information Disclosure Citation together with copies of patents, publications or other information of which applicants are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

Each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement, as evidenced by the enclosed copy of the Search Report.

It is requested that the information disclosed herein be made of record in this application.

PLEASE MAIL CORRESPONDENCE TO:

Siemens Corporation
Attn: Elsa Keller, Legal Administrator
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Iselin, NJ 08830

Respectfully submitted,

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OCT 27 1999

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit: October 20, 1999

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Signature

Raquel C. West